Docket No.: 1592-0164PUS1

(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of: Eiichi SHIMIZU et al.

Application No.: 10/589,348

Confirmation No.: 8171

Filed: August 11, 2006

Art Unit: 1792

For: VAPOR PHASE GROWTH APPARATUS Examiner: V. Bernard

AMENDMENT IN RESPONSE TO NON-FINAL OFFICE ACTION

MS Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated March 11, 2008, please amend the aboveidentified U.S. patent application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 4 of this paper.